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Substitute for form 1449A/PTO

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Complete if Known

Application Number	09/295,607
Filing Date	4-22-1999
First Named Inventor	Shunpei YAMAZAKI et al.
Group Art Unit	2811
Examiner Name	Steven Loke
Attorney Docket Number	740756-1961

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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴ <i>(if known)</i>	Kind Code ⁵				
Luke		EP	0 456 199 A2		Kunio Masumo et al.	11/13/1991		.Full

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Examiner Signature	Loke		Date Considered 1/10/03

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

Application Number	09/295,607
Filing Date	April 22, 1999
First Named Inventor	Shunpei YAMAZAKI et al.
Art Unit	2811
Examiner Name	Steven Ho Yin Loke
Attorney Docket Number	740756-1961

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U.S. PATENT DOCUMENTS

Examiner Initials [*]	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
Loke		US-4,094,058	06/13/1978	Yasutake et al.	
		US-4,394,182	07/19/1983	Maddox III	
		US-5,492,582	02/20/1996	Ide et al.	
		US-5,523,257	06/04/1996	Yamazaki et al.	
		US-5,650,338	07/22/1997	Yamazaki et al.	
		US-5,677,240	10/14/1997	Murakami et al.	
		US-5,706,069	01/06/1998	Hermens et al.	
		US-5,736,750	04/07/1998	Yamazaki et al.	
		US-5,849,611	12/15/1998	Yamazaki et al.	
		US-5,891,766	04/06/1999	Yamazaki et al.	
		US-5,899,709	05/04/1999	Yamazaki et al.	
		US-5,982,469	11/09/1999	Awane et al.	
		US-6,099,672	08/08/2000	Yamazaki et al.	
		US-6,114,728	09/05/2000	Yamazaki et al.	
		US-6,201,591	03/13/2001	Awane et al.	
		US-6,326,225	12/04/2001	Yamazaki et al.	
		US-6,327,015	12/04/2001	Awane et al.	
		US-6,358,784	03/19/2002	Zhang et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials [*]	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
Loke		JP 02-105115	04-17-1990	Saburo Oikawa et al.		AB
		JP 07-199163	08-04-1995	Shunji Suzuki et al.		AB
		JP 60-154660	08-04-1985	Seikosha Suwa		AB
		JP 63-296379	12-02-1988	Hiroya SATO et al.		AB

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Loke		Ito et al. "Thin Film Technology of VLSI" pp 87-88, published on September 30, 1986 by Maruzen Co., Ltd. (with English Abstract)	
Loke		Tokuyama et al., "VLSI Manufacturing Technology", pp. 194-195, Published on January 14, 1989 by Nikkei BP Co., Ltd. (with English Abstract)	
Loke		IEEE Electron Device Letters; T.I. Kamins et al. "MOSFETs-in LKaser-Recrystallized Poly-Silicon on Quartz" Vo. EDL-1 No. 10, pp. 214-216 (with English Abstract)	

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